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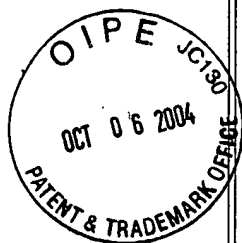
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2623

OCT 14 2004

Technology Center 2600

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



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Application of :
Ryoichi MATSUOKA :
Serial No. 09/903,600 : Group Art Unit - 2623
Filed: July 12, 2001 : Examiner - Virginia Kibler
For: WAFER PATTERN OBSERVATION :
METHOD AND DEVICE : Docket No. S004-4331

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MS NON-FEE AMENDMENT
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

S I R:

In response to the Office Action dated July 2, 2004,
applicant amends his application as follows:

ADDITIONAL FEES:

No additional fees are believed required in
connection with this response; however, should it be
determined that a fee is due, authorization is hereby given to
charge any such fee to our Deposit Account No. 01-0268.

MAILING CERTIFICATE ON PAGE 21